

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	BRS	L2	18156	teos	USPAT; US-PGPUB ; EPO; JPO; DERWENT ; IBM_TDB	2003/10 /30 11:38
2	BRS	L3	62646	electro-optic\$5 or electrooptic\$5 or (electro adj2 optic\$5)	USPAT; US-PGPUB ; EPO; JPO; DERWENT ; IBM_TDB	2003/10 /30 11:38
3	BRS	L4	510	teos and (electro-optic\$5 or electrooptic\$5 or (electro adj2 optic\$5))	USPAT; US-PGPUB ; EPO; JPO; DERWENT ; IBM_TDB	2003/10 /30 11:38
4	BRS	L5	4494	plzt	USPAT; US-PGPUB ; EPO; JPO; DERWENT ; IBM_TDB	2003/10 /30 11:39
5	BRS	L6	12	(teos and (electro-optic\$5 or electrooptic\$5 or (electro adj2 optic\$5))) and plzt	USPAT; US-PGPUB ; EPO; JPO; DERWENT ; IBM_TDB	2003/10 /30 11:39

09/89/689

	<del>Document ID</del>	<del>1</del>	S u r c e	Issue Date	Pa ge s	Title	Current OR	Current XRef
1	US 20020064897 A1	<input checked="" type="checkbox"/>	U S - P G P U B	20020 530	7	Silica-based optical device fabrication	438/31	427/585